



# 124

Patent  
Attorney's Docket No. 015290-458

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

Christopher C. CHANG et al.

Application No.: 09/749,917

Filed: December 29, 2000

For: LOW CONTAMINATION PLASMA  
CHAMBER COMPONENTS AND  
METHODS FOR MAKING THE SAME

Group Art Unit: 1773

Examiner: N. Uhler

Confirmation No.: 6832

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OCT 24 2002  
TC 1700

**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, Applicants hereby submit a copy of the Written Opinion dated October 4, 2002 for a corresponding application. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited in the Search Report but not of record in the present application is enclosed.

Written Opinion for PCT/US01/47571 dated October 4, 2002

I, the undersigned, hereby state that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart application and that this communication was not received by any individual designated in § 1.56(c) more than 30 (thirty) days prior to the filing of this Information Disclosure Statement.

To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

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